						Page 1 of	1
FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office List of Documents Cited by Applicant					Application No.	10/523,948	
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Examiner Initial	Cite No.	Document Number	Publication Date	Name	of Patentee or Applicant of Cited Document	Pages, Columns, Lines where relevant passages relevant figures appear	or
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	4	International Search Report for corresponding PCT Appl. No. PCT/US03/25015 dated April 24, 2004.					
	2	International-Proliminary-Examination-Report for corresponding PCT Appl. No. PCT/US03/25015 dated June 9, 2004.					
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EXAMINER	'	/Shirley Gembeh/	D	ATF CO	DNSIDERED 5/27/08		

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